



US009177897B1

(12) **United States Patent**
Do et al.

(10) **Patent No.:** **US 9,177,897 B1**
(45) **Date of Patent:** **Nov. 3, 2015**

(54) **INTEGRATED CIRCUIT PACKAGING
SYSTEM WITH TRACE PROTECTION
LAYER AND METHOD OF MANUFACTURE
THEREOF**

USPC 257/737, 738, 786, 784, 773, 774, 666,
257/698, 692–696, 676, E23.031, E21.505,
257/E21.506; 438/123

See application file for complete search history.

(71) Applicants: **Byung Tai Do**, Singapore (SG); **Arnel
Senosa Trasporto**, Singapore (SG);
Linda Pei Ee Chua, Singapore (SG);
Henry Descalzo Bathan, Singapore
(SG)

(56) **References Cited**

U.S. PATENT DOCUMENTS

6,255,740	B1	7/2001	Tsuji et al.	
6,964,918	B1	11/2005	Fan et al.	
7,232,755	B1	6/2007	McLellan et al.	
7,662,672	B2	2/2010	Lin	
7,741,149	B2	6/2010	Qiao et al.	
8,129,229	B1	3/2012	Sirinorakul et al.	
8,455,304	B2	6/2013	Lam	
8,987,060	B2	3/2015	Yen	
2005/0199995	A1	9/2005	Nomoto et al.	
2009/0302445	A1*	12/2009	Pagaila et al.	257/678
2011/0074026	A1	3/2011	Shim et al.	
2011/0079885	A1*	4/2011	Camacho et al.	257/676
2011/0227211	A1*	9/2011	Camacho et al.	257/692
2012/0007234	A1	1/2012	Tsai et al.	
2012/0139104	A1*	6/2012	Camacho et al.	257/737
2012/0146200	A1	6/2012	McMillan et al.	
2012/0181680	A1	7/2012	Li	
2012/0205811	A1*	8/2012	Do et al.	257/773

(Continued)

OTHER PUBLICATIONS

U.S. Appl. No. 13/930,287, filed Jun. 28, 2013, Dimaculangan et al.

(Continued)

Primary Examiner — Alexander Oscar Williams

(74) *Attorney, Agent, or Firm* — Ishimaru & Associates LLP

(57) **ABSTRACT**

An integrated circuit packaging system and method of manufacture thereof including: providing a pre-plated leadframe having a contact protrusion and a protective pad on the contact protrusion; forming a contact pad and traces by etching the pre-plated leadframe; applying a trace protection layer on the contact pad, the traces, and the protective pad; removing the protective pad and a portion of the trace protection layer for exposing the contact pad; and depositing an external connector directly on a surface of the contact pad.

20 Claims, 10 Drawing Sheets

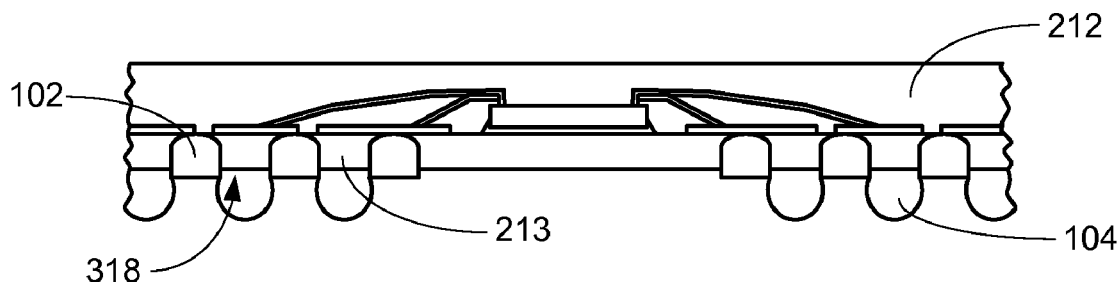
(21) Appl. No.: **13/930,319**

(22) Filed: **Jun. 28, 2013**

(51) **Int. Cl.**
H01L 23/495 (2006.01)
H01L 21/00 (2006.01)
H01L 21/56 (2006.01)
H01L 21/48 (2006.01)

(52) **U.S. Cl.**
CPC **H01L 23/49517** (2013.01); **H01L 21/4825**
(2013.01)

(58) **Field of Classification Search**
CPC H01L 23/495; H01L 21/56; H01L 21/565;
H01L 23/49861; H01L 23/3128; H01L
2224/73204; H01L 2224/32145; H01L
2224/48091; H01L 2224/73265; H01L
21/4828; H01L 23/49848; H01L 23/49582;
H01L 2924/3025; H01L 2224/00013; H01L
2924/00



(56)

References Cited

U.S. PATENT DOCUMENTS

2012/0241973 A1* 9/2012 Chua et al. 257/774
 2012/0280376 A1* 11/2012 Do et al. 257/675
 2012/0280377 A1* 11/2012 Do et al. 257/676
 2012/0280407 A1* 11/2012 Do et al. 257/778
 2013/0154072 A1* 6/2013 Do et al. 257/676
 2013/0154119 A1* 6/2013 Do et al. 257/778

2013/0256861 A1* 10/2013 Do et al. 257/676
 2014/0008774 A1* 1/2014 Do et al. 257/666
 2014/0165389 A1* 6/2014 Do et al. 29/825
 2014/0167236 A1* 6/2014 Do et al. 257/676
 2015/0084172 A1 3/2015 Do et al.

OTHER PUBLICATIONS

U.S. Appl. No. 13/930,261, filed Jun. 28, 2013, Do et al.

* cited by examiner

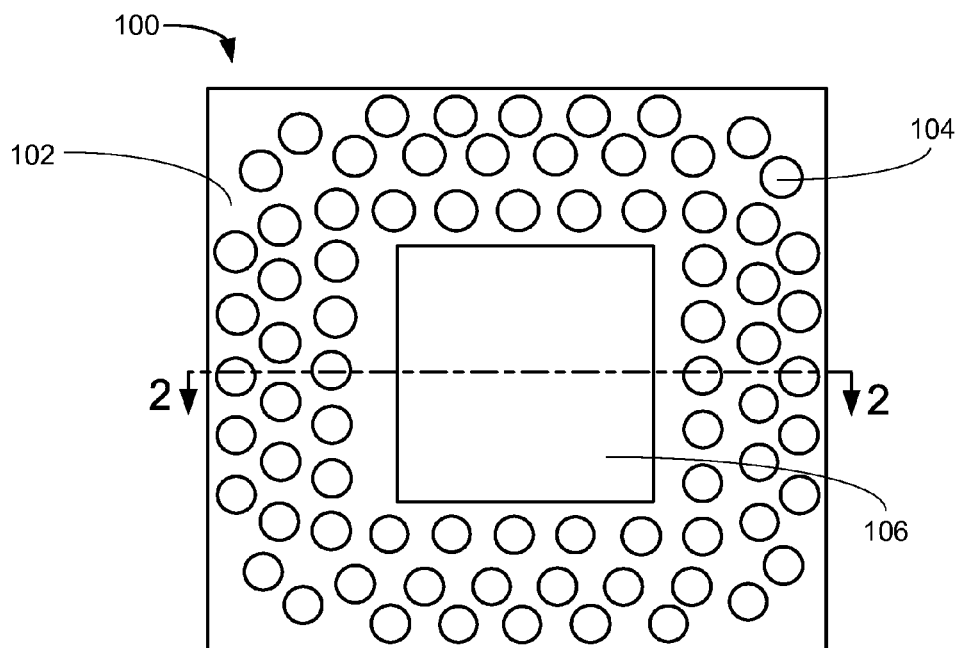


FIG. 1

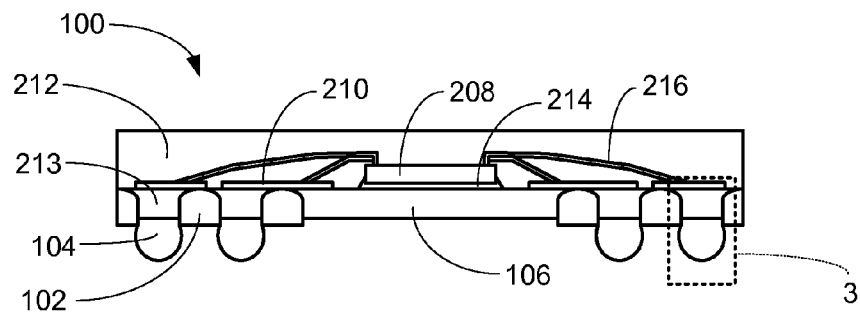


FIG. 2

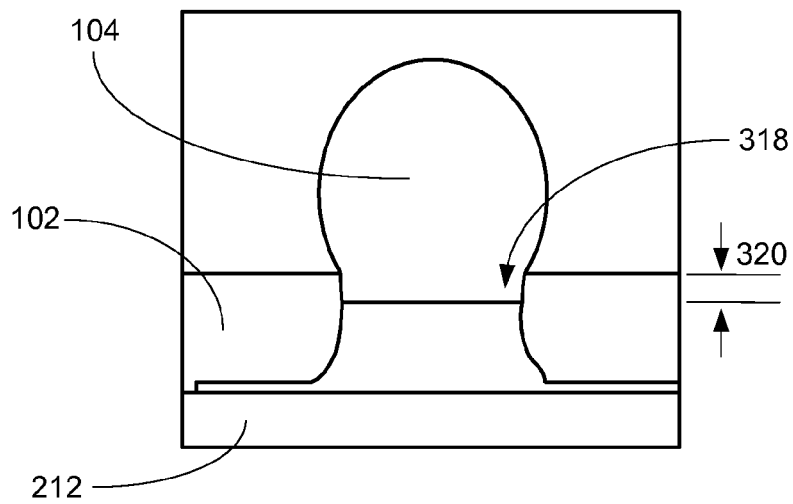


FIG. 3

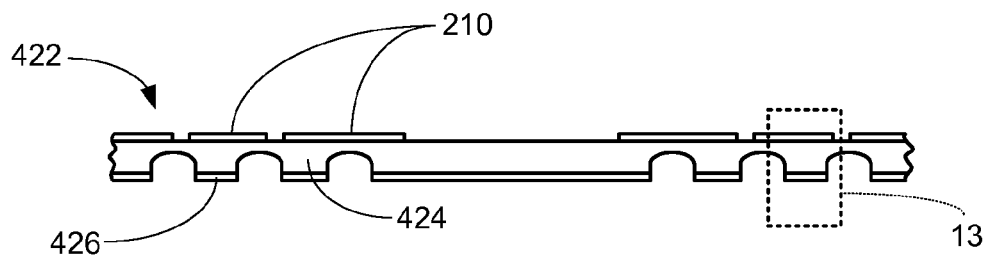


FIG. 4

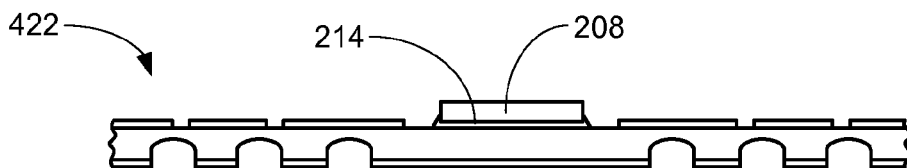


FIG. 5

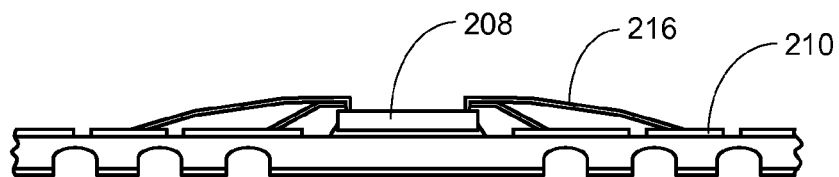


FIG. 6

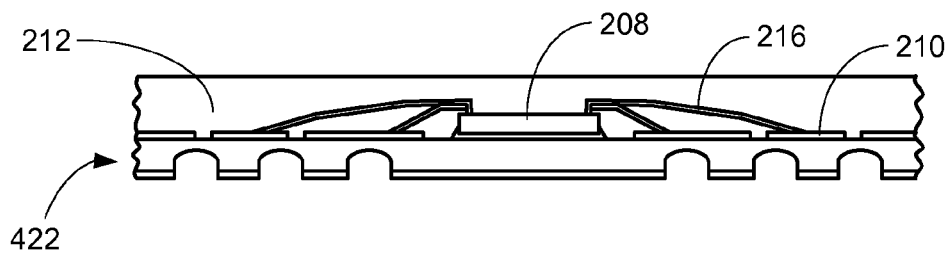


FIG. 7

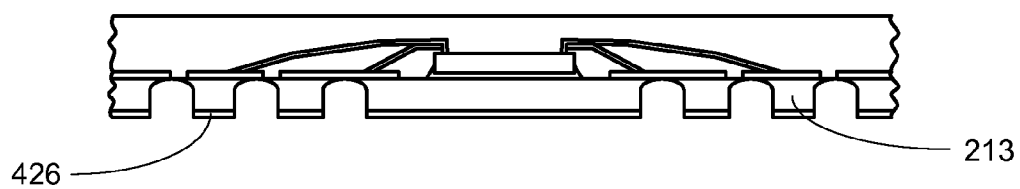


FIG. 8

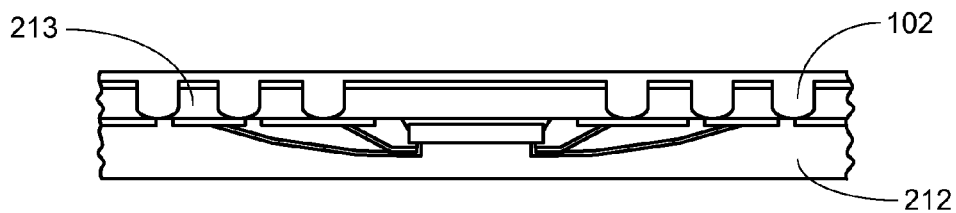


FIG. 9

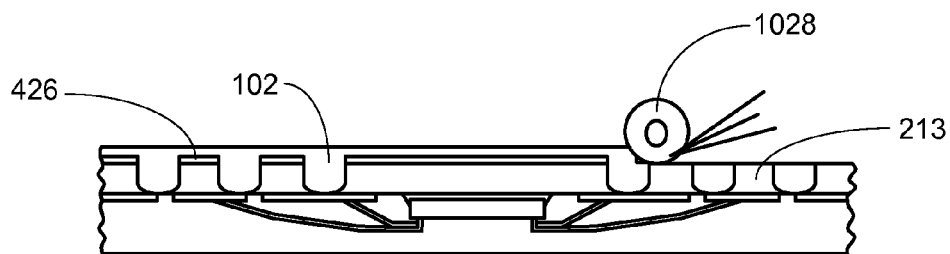


FIG. 10

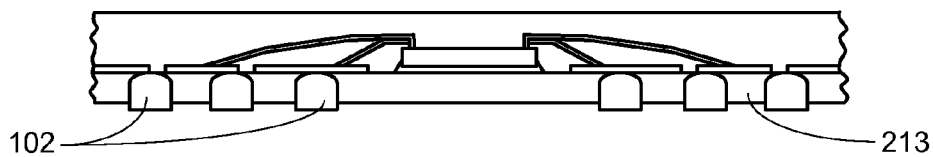


FIG. 11

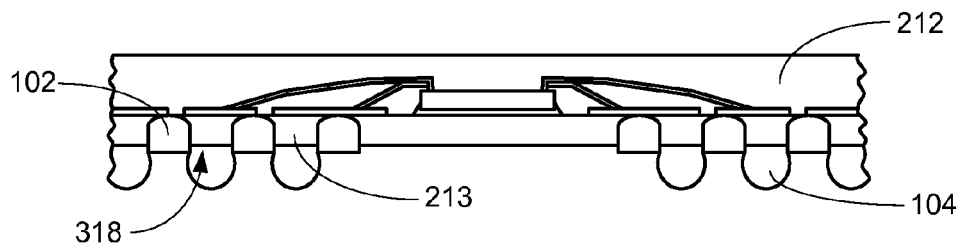


FIG. 12

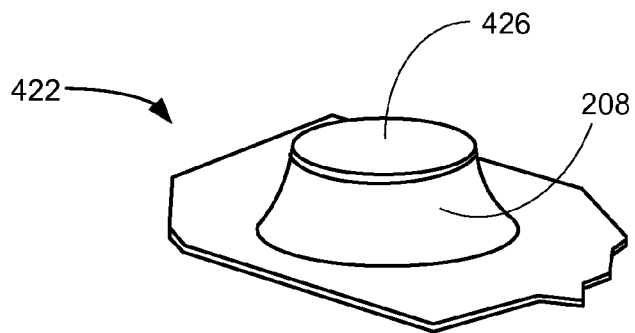


FIG. 13

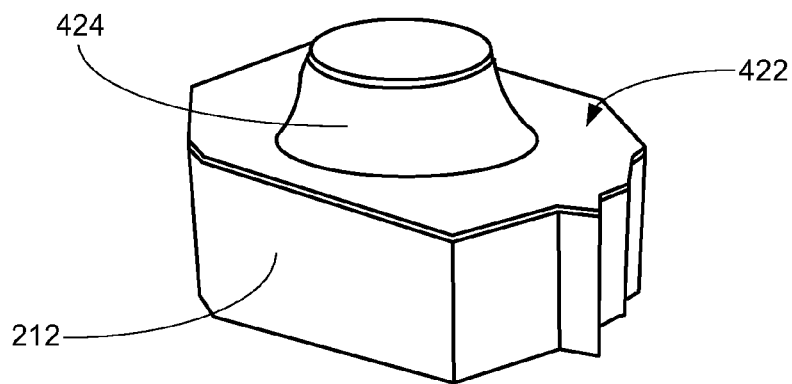


FIG. 14

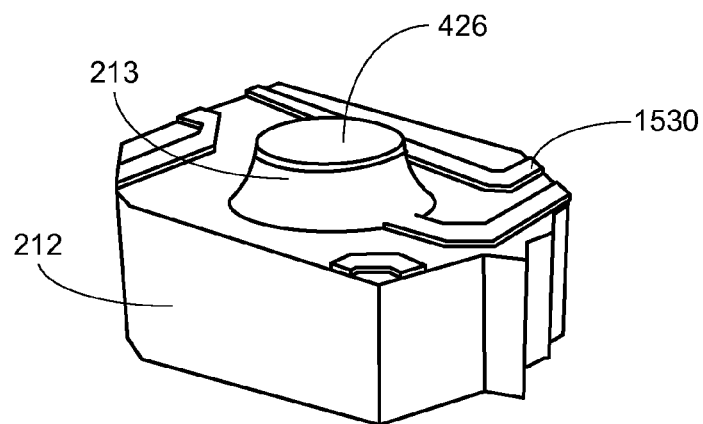


FIG. 15

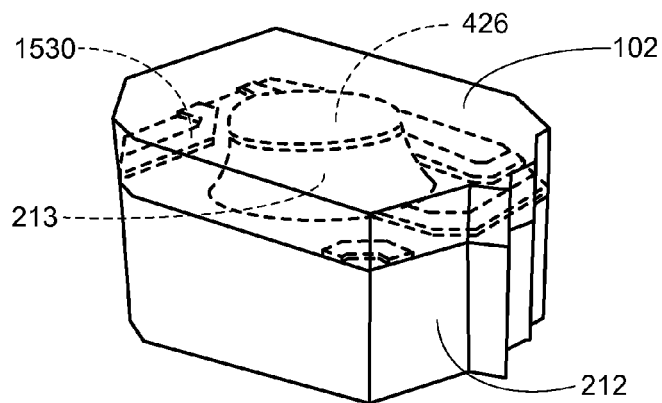


FIG. 16

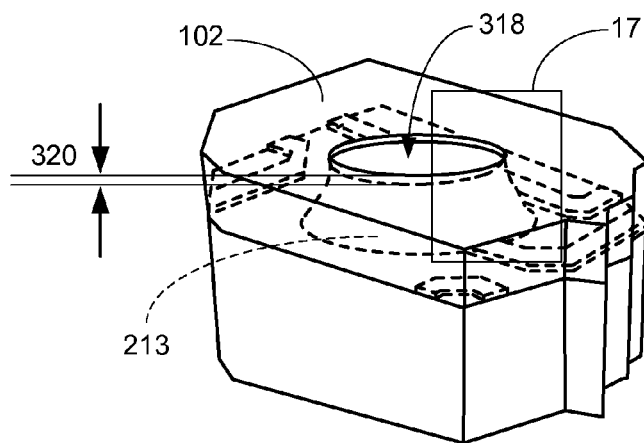


FIG. 17A

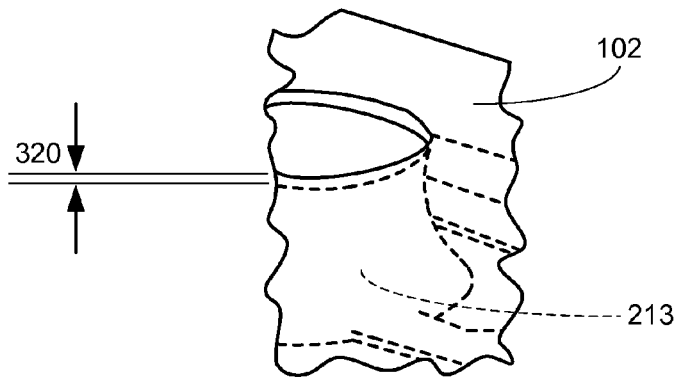


FIG. 17B

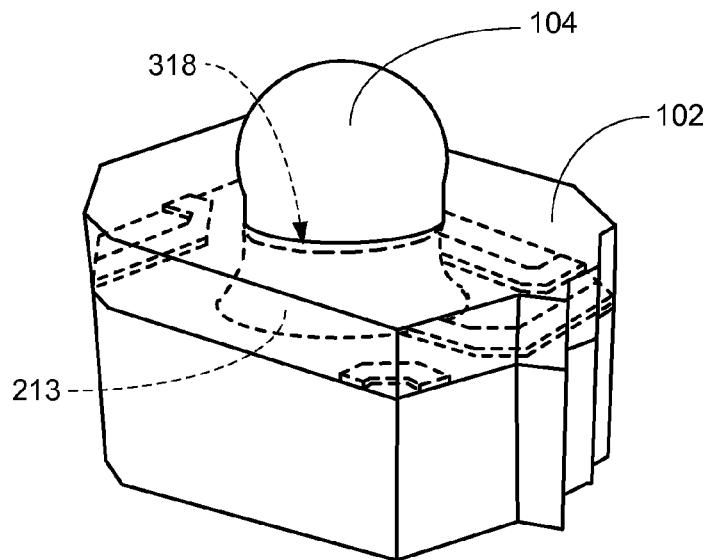


FIG. 18

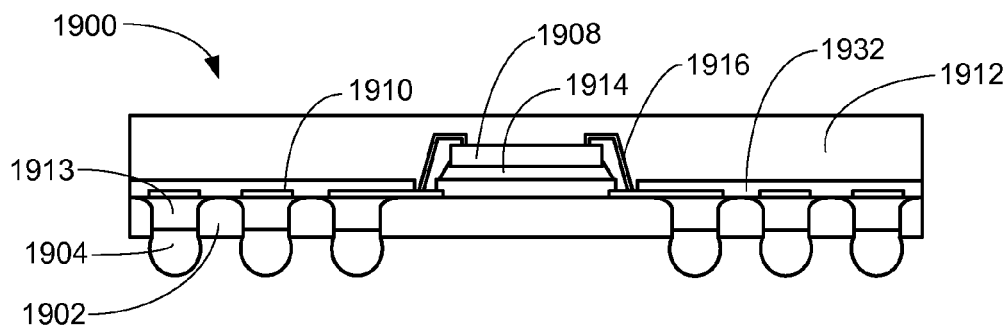


FIG. 19A

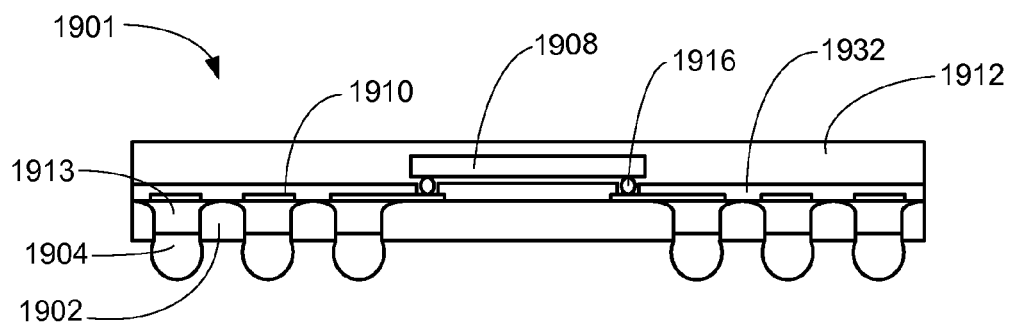
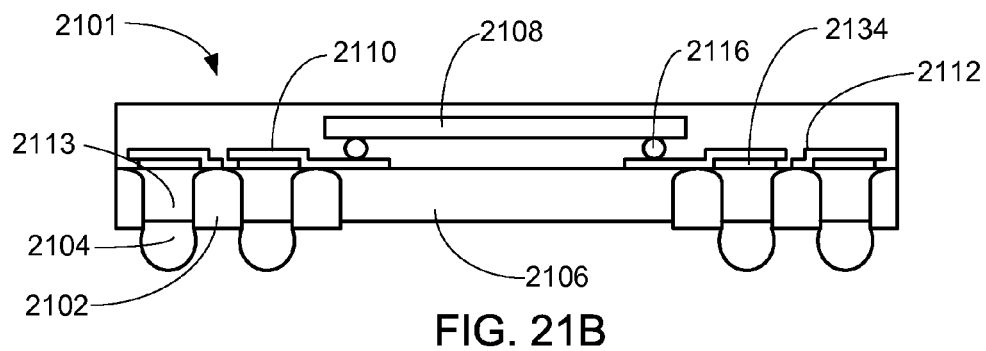
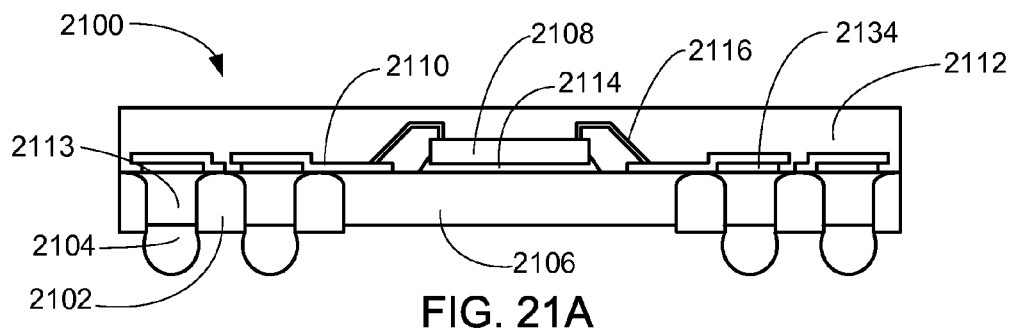
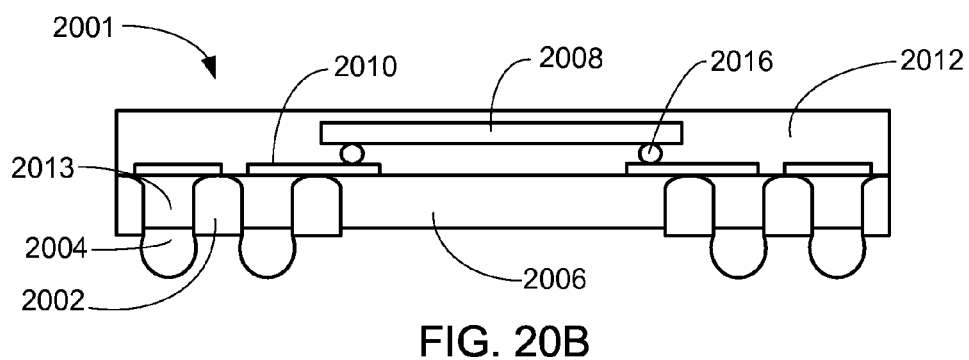
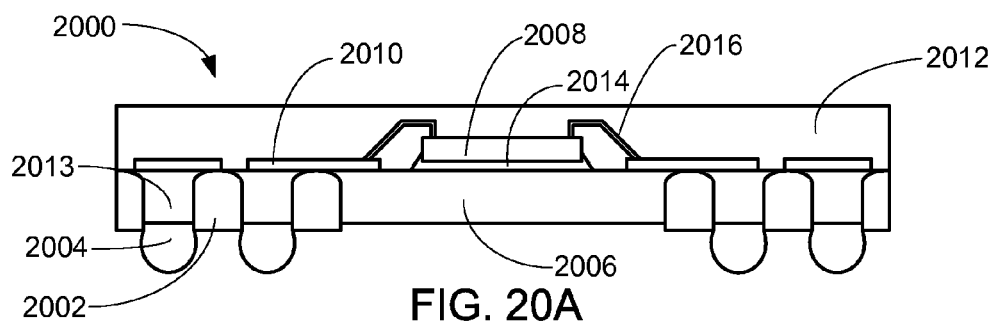
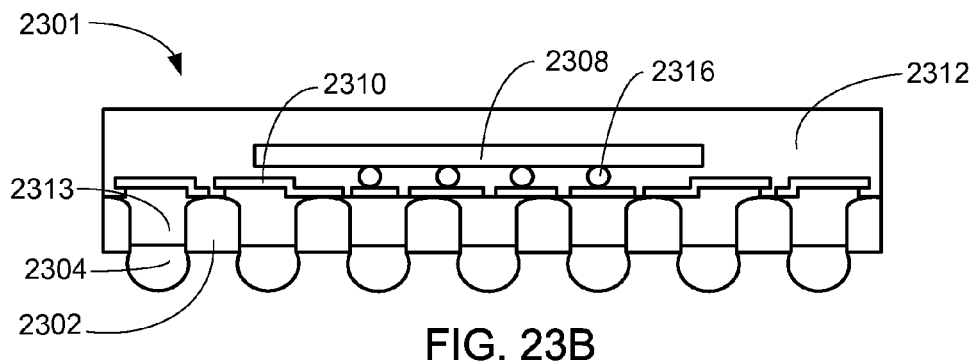
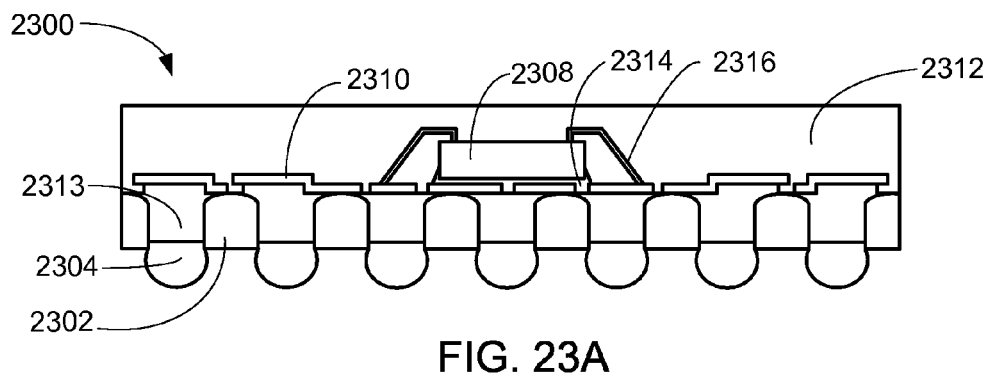
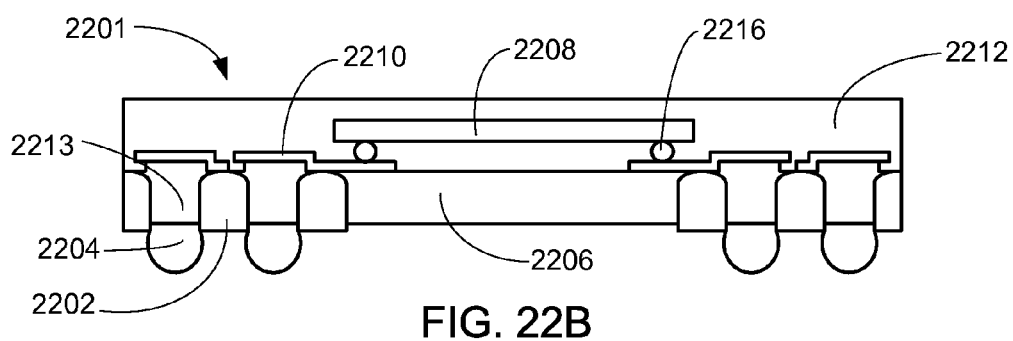
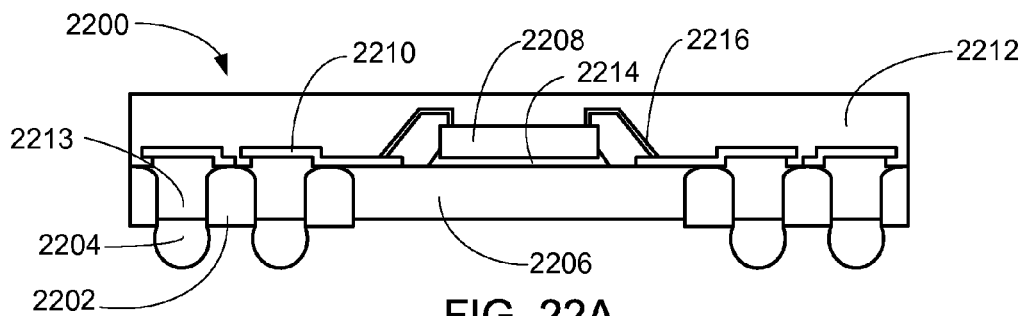


FIG. 19B





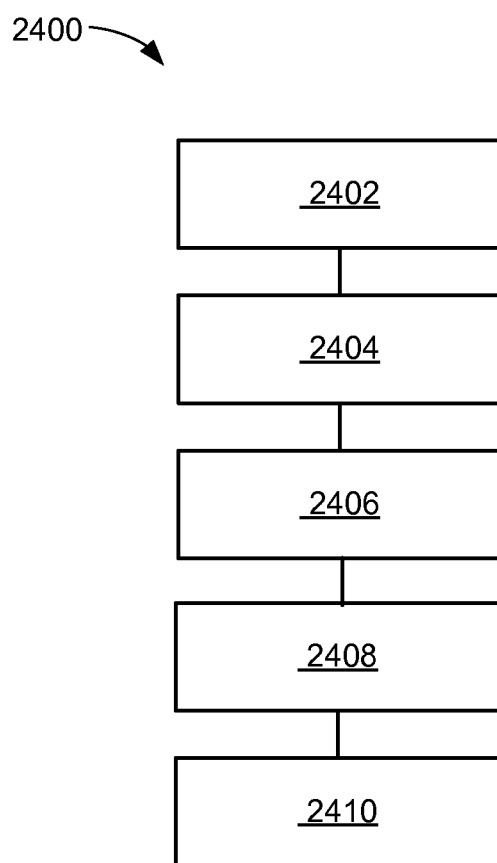


FIG. 24

1

INTEGRATED CIRCUIT PACKAGING SYSTEM WITH TRACE PROTECTION LAYER AND METHOD OF MANUFACTURE THEREOF

CROSS-REFERENCE TO RELATED APPLICATION(S)

The present application contains subject matter related to concurrently filed U.S. patent application Ser. No. 13/930,261. The related application is assigned to STATS ChipPAC Ltd. and the subject matter thereof is incorporated herein by reference thereto.

The present application contains subject matter related to concurrently filed U.S. patent application Ser. No. 13/930,287. The related application is assigned to STATS ChipPAC Ltd. and the subject matter thereof is incorporated herein by reference thereto.

TECHNICAL FIELD

The present invention relates generally to an integrated circuit packaging system, and more particularly to a system formed from a leadframe.

BACKGROUND ART

Semiconductor chips have become progressively more complex, driven in large part by the need for increasing processing power in a smaller chip size for compact or portable electronic devices such as cell phones, smart phones, personal media systems, ultraportable computers.

There are a number of conventional processes for packaging integrated circuit (IC) dice. By way of example, many IC packages utilize a metallic leadframe that has been stamped or etched from a metal sheet to provide electrical interconnects to external devices. The die may be electrically connected to the leadframe by means of bonding wires, solder bumps or other suitable electrical connections.

In general, a leadframe will come from a supplier pre-plated with a desired pattern for further processing. The plating can protect selected portions of the leadframe during processing steps, and traces formed during processing require protection. The die and portions of the leadframe are encapsulated with a molding material to protect the delicate electrical components on the active side of the die while leaving selected portions of the leadframe exposed to facilitate electrical connection to external devices.

Thus, a need still remains for a better manufacturing system. In view of the rising costs of materials, it is increasingly critical that answers be found to these problems. In view of the ever-increasing commercial competitive pressures, along with growing consumer expectations and the diminishing opportunities for meaningful product differentiation in the marketplace, it is critical that answers be found for these problems. Additionally, the need to reduce costs, improve efficiencies and performance, and meet competitive pressures adds an even greater urgency to the critical necessity for finding answers to these problems.

Solutions to these problems have been long sought but prior developments have not taught or suggested any solutions and, thus, solutions to these problems have long eluded those skilled in the art.

DISCLOSURE OF THE INVENTION

The present invention provides a method of manufacture of an integrated circuit packaging system including: providing a

2

pre-plated leadframe having a contact protrusion and a protective pad on the contact protrusion; forming a contact pad and traces by etching the pre-plated leadframe; applying a trace protection layer on the contact pad, the traces, and the protective pad; removing the protective pad and a portion of the trace protection layer for exposing the contact pad; and depositing an external connector directly on a surface of the contact pad.

The present invention provides an integrated circuit packaging system, including: an integrated circuit die; a contact pad connected to the integrated circuit die; traces connected to the contact pad; a trace protection layer on the contact pad and the traces, the trace protection layer having a recess with a top surface of the contact pad spaced a recess distance away from an exposed surface of the trace protection layer; and an external connector directly on the top surface of the contact pad.

Certain embodiments of the invention have other steps or elements in addition to or in place of those mentioned above. The steps or element will become apparent to those skilled in the art from a reading of the following detailed description when taken with reference to the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a bottom view an integrated circuit packaging system in a first embodiment of the present invention.

FIG. 2 is a cross-sectional view of FIG. 1 along the section line 2-2 of FIG. 1.

FIG. 3 is a detailed cross-sectional view of FIG. 2 within the inset depicted by the dotted rectangle 3 of FIG. 2.

FIG. 4 is a cross-sectional view of FIG. 1 along the section line 2-2 of FIG. 1 in a beginning phase of manufacture.

FIG. 5 is the structure of FIG. 4 in a die attach phase of manufacture.

FIG. 6 is the structure of FIG. 5 in a wire bond phase of manufacture.

FIG. 7 is the structure of FIG. 6 in a first molding phase of manufacture.

FIG. 8 is the structure of FIG. 7 in a first etching phase of manufacture.

FIG. 9 is the structure of FIG. 8 in a second molding phase of manufacture.

FIG. 10 is the structure of FIG. 9 in a backgrinding phase of manufacture.

FIG. 11 is the structure of FIG. 10 in a second etching phase of manufacture.

FIG. 12 is the structure of FIG. 11 in a ball attach phase of manufacture.

FIG. 13 is a detailed isometric view of FIG. 4 within the inset depicted by the dotted rectangle 13 of FIG. 4.

FIG. 14 is the structure of FIG. 13 in a first molding phase of manufacture.

FIG. 15 is the structure of FIG. 14 in a first etching phase of manufacture.

FIG. 16 is the structure of FIG. 15 in a second molding phase of manufacture.

FIG. 17A is the structure of FIG. 16 in a second etching phase of manufacture.

FIG. 17B is a detailed view of FIG. 17A within the inset depicted by the solid rectangle 17 of FIG. 17A.

FIG. 18 is the structure of FIG. 17A in a ball attach phase of manufacture.

FIG. 19A is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a second embodiment of the present invention.

3

FIG. 19B is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a third embodiment of the present invention.

FIG. 20A is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a fourth embodiment of the present invention.

FIG. 20B is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a fifth embodiment of the present invention.

FIG. 21A is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a sixth embodiment of the present invention.

FIG. 21B is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a seventh embodiment of the present invention.

FIG. 22A is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in an eighth embodiment of the present invention.

FIG. 22B is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a ninth embodiment of the present invention.

FIG. 23A is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a tenth embodiment of the present invention.

FIG. 23B is a cross-sectional view of the integrated circuit packaging system as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in an eleventh embodiment of the present invention.

FIG. 24 is a flow chart of a method of manufacture of the integrated circuit packaging system in a further embodiment of the present invention.

BEST MODE FOR CARRYING OUT THE INVENTION

The following embodiments are described in sufficient detail to enable those skilled in the art to make and use the invention. It is to be understood that other embodiments would be evident based on the present disclosure, and that system, process, or mechanical changes may be made without departing from the scope of the present invention.

In the following description, numerous specific details are given to provide a thorough understanding of the invention. However, it will be apparent that the invention may be practiced without these specific details. In order to avoid obscuring the present invention, some well-known circuits, system configurations, and process steps are not disclosed in detail.

The drawings showing embodiments of the system are semi-diagrammatic and not to scale and, particularly, some of the dimensions are for the clarity of presentation and are shown exaggerated in the drawing FIGS. Similarly, although the views in the drawings for ease of description generally show similar orientations, this depiction in the FIGS. is arbitrary for the most part. Generally, the invention can be operated in any orientation.

Where multiple embodiments are disclosed and described having some features in common, for clarity and ease of illustration, description, and comprehension thereof, similar and like features one to another will ordinarily be described

4

with similar reference numerals. The embodiments have been numbered first embodiment, second embodiment, etc. as a matter of descriptive convenience and are not intended to have any other significance or provide limitations for the present invention.

For expository purposes, the term “horizontal” as used herein is defined as a plane parallel to the plane or surface of the contact pad, regardless of its orientation. The term “vertical” refers to a direction perpendicular to the horizontal as just defined. Terms, such as “above”, “below”, “bottom”, “top”, “side” (as in “sidewall”), “higher”, “lower”, “upper”, “over”, and “under”, are defined with respect to the horizontal plane, as shown in the figures. The term “on” means that there is direct contact between elements. The term “directly on” means that there is direct contact between one element and another element without an intervening element.

The term “active side” refers to a side of a die, a module, a package, or an electronic structure having active circuitry fabricated thereon or having elements for connection to the active circuitry within the die, the module, the package, or the electronic structure.

The term “processing” as used herein includes deposition of material or photoresist, patterning, exposure, development, etching, cleaning, and/or removal of the material or photoresist as required in forming a described structure.

Referring now to FIG. 1, therein is shown a bottom view an integrated circuit packaging system 100 in a first embodiment of the present invention. The bottom view shows a trace protection layer 102, external connectors 104, and a die paddle 106.

The trace protection layer 102 protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer 102 is shown as opaque, but it is understood that a translucent or transparent material may be used.

The external connectors 104, such as solder balls, can be connected to contact pads through the trace protection layer 102. The external connectors 104 function to electrically connect an integrated circuit die, which is mounted to an internal side of the die paddle 106, to the outside of the integrated circuit packaging system 100. The external connectors 104 can be arranged in an array as seen or can be arranged in a staggered, regular, or irregular array, for example. The die paddle 106 can function to dissipate heat or to provide a path to ground for the integrated circuit die.

Referring now to FIG. 2, therein is shown a cross-sectional view of FIG. 1 along the section line 2-2 of FIG. 1. The cross-sectional view shows an integrated circuit die 208, bond structures 210, an encapsulation 212, contact pads 213, the die paddle 106, the trace protection layer 102, and the external connectors 104. The integrated circuit die 208, such as a wire-bond die or a flip chip die, can be mounted to the die paddle 106 using a die attach adhesive 214. The die attach adhesive 214 can contact the bottom and a portion of the sides of the integrated circuit die 208.

The die paddle 106 can be laterally surrounded by the contact pads 213, which are made from the same material as the die paddle 106. For example, the die paddle 106 and the contact pads 213 can be made from a conductive material such as copper or a copper alloy. The die paddle 106 and the contact pads 213 can have partially curved sides as a result of an etching process. The contact pads 213 are in direct contact with the external connectors 104 on a bottom surface and in direct contact with the bond structures 210 on a top surface. The bond structures 210 can be planar.

5

The bond structures **210** can route electrical signals from the integrated circuit die **208** to the contact pads **213** directly or through traces, which will be described in greater detail in a later figure. The bond structures **210** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, or other metal. The integrated circuit die **208** is connected to the bond structures **210** and further to the contact pads **213** and the external connectors **104** through internal interconnects **216**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **212** directly contacts the integrated circuit die **208**, the bond structures **210**, and the internal interconnects **216**. The encapsulation **212** also is in direct contact with portions of the trace protection layer **102** between the contact pads **213**. The encapsulation **212** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **213** and the die paddle **106** are recessed into the trace protection layer **102**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **213** without intervening plating. The external connectors **104** also directly contact the trace protection layer **102**. The external connectors **104** also directly contact the trace protection layer **102**, creating a stronger solder joint.

Referring now to FIG. 3, therein is shown a detailed cross-sectional view of FIG. 2 within the inset depicted by the dotted rectangle 3 of FIG. 2. The detailed cross-sectional view is shown in a flipped orientation as compared to FIG. 2. The bond structures **210** and the internal interconnects **216** of FIG. 2 are omitted for clarity. Clearly seen at the left side of this view is the boundary between the encapsulation **212** and the trace protection layer **102**. The encapsulation **212** and the trace protection layer **102** can be made from the same or different material, but as the encapsulation **212** and the trace protection layer **102** are applied at different times, a boundary between the two will always exist.

Also seen in this detailed view is a recess **318** in the trace protection layer **102** wherein a surface of the contact pads **213** is the bottom of the recess **318** and is a recess distance **320** below the exposed surface of the trace protection layer **102**. The recess distance **320** is defined as the distance between the exposed surface of the trace protection layer **102** and the surface of the contact pads **213** closest to the exposed surface of the trace protection layer **102**. The exposed surface of the trace protection layer **102** is flat and planar as a result of a backgrinding process, enhancing solder joint strength. One of the external connectors **104** can be seen in this detailed view.

Referring now to FIG. 4, therein is shown a cross-sectional view of FIG. 1 along the section line 2-2 of FIG. 1 in a beginning phase of manufacture. The cross-sectional view shows a pre-plated leadframe **422** having a number of contact protrusions **424**, with the bond structures **210** and protective pads **426** shown pre-deposited on the pre-plated leadframe **422**. Wavy lines at the sides of the figure indicate that only a portion of the structure is shown.

The pre-plated leadframe **422** can be pre-stamped or pre-etched metal, such as copper or a copper alloy, such that the contact protrusions **424** of the pre-plated leadframe **422** can function as the contact pads **213** and the die paddle **106** of FIG. 2 after further processing. The contact protrusions **424** can have curved sides as a result of an etching process. The contact protrusions **424** can be formed by etching through most or half of the thickness of the pre-plated leadframe **422**. The protective pads **426** can be made from an etch-resistant material such as gold, platinum, palladium, nickel, or other etch-resistant metal.

6

Referring now to FIG. 5, therein is shown the structure of FIG. 4 in a die attach phase of manufacture. The integrated circuit die **208** is attached to a center of the pre-plated leadframe **422** using the die attach adhesive **214**.

Referring now to FIG. 6, therein is shown the structure of FIG. 5 in a wire bond phase of manufacture. The integrated circuit die **208** is connected to the bond structures **210** through the internal interconnects **216**. For example, the integrated circuit die **208** can be connected to various points of the bond structures **210** using bond wires.

Referring now to FIG. 7, therein is shown the structure of FIG. 6 in a first molding phase of manufacture. The integrated circuit die **208**, the internal interconnects **216**, one side of the pre-plated leadframe **422**, and the bond structures **210** are covered by the encapsulation **212**. The encapsulation **212** can be applied through a process such as injection molding, film-assist molding, or other encapsulation process.

Referring now to FIG. 8, therein is shown the structure of FIG. 7 in a first etching phase of manufacture. The protective pads **426** can protect a portion of the contact protrusions **424** of FIG. 4 from the etching process by resisting the etchant. The etching process can be anisotropic or isotropic and can etch away a portion of the contact protrusions **424**, forming the contact pads **213** and traces and electrically separating the contact pads **213** from each other. The etchant can be formulated to only etch through the material between the contact protrusions **424**.

Referring now to FIG. 9, therein is shown the structure of FIG. 8 in a second molding phase of manufacture. In this figure, the view is flipped as compared to FIG. 8. After the first etching step to form the contact pads **213**, a second molding step is performed to apply the trace protection layer **102** to fully cover the contact pads **213**. The trace protection layer **102** can be formed from the same material as the encapsulation **212** or from a different material. It is preferred for the purposes of preventing warpage and ease of manufacturing to use the same material as used to form the encapsulation **212**.

It has been discovered that the use of the same material for the trace protection layer **102** as the encapsulation **212** helps prevent warpage issues in the completed package. Warpage of a package generally occurs due to differences in the coefficient of thermal expansion between different materials. When the trace protection layer **102** and the encapsulation **212** are made from the same material, their coefficients of thermal expansion are exactly matched, helping to prevent the package from warping. This can also help prevent delamination between the encapsulation **212** and the trace protection layer **102**.

Referring now to FIG. 10, therein is shown the structure of FIG. 9 in a backgrinding phase of manufacture. A backgrinding tool **1028** is shown in the process of grinding away a portion of the trace protection layer **102**, the protective pads **426**, and a portion of the contact pads **213**. The backgrinding step leaves the surface of the trace protection layer **102** and the contact pads **213** coplanar and flat.

It has been discovered that the use of the backgrinding tool **1028** for backgrinding rather than a buffing or chemical mechanical polishing (CMP) process for removal of excess material leads to a faster, more reliable, and more cost-effective manufacturing process. Because the grinding process removes more material more quickly than buffing or CMP, larger tolerances in the application of the trace protection layer **102** are possible, allowing the use of equipment with lower precision than would otherwise be necessary. The trace protection layer **102** can be applied in a thick coating without impacting the manufacturing process.

It has also been discovered that the use of the backgrinding tool **1028** for backgrinding rather than buffing or CMP allows for better protecting of traces through the use of a harder material for the trace protection layer **102** than if using buffing or CMP. Because the grinding process is able to remove material at roughly the same rate whether hard or soft, a greater variety of materials, such as epoxy molding compound, become realistically useable for the trace protection layer **102** as compared to when buffing or CMP is used.

It has also been discovered that the use of the backgrinding tool **1028** rather than simply molding and curing the trace protection layer **102** on and around the contact pads **213** improves solder joint and material strength. Because the curing process for materials used in trace protection causes some amount of shrinkage and an uneven surface, it has been found that grinding a planar surface increases reliability by ensuring uniformity across the entire surface of the trace protection layer **102**.

Referring now to FIG. **11**, therein is shown the structure of FIG. **10** in a second etching phase of manufacture. The view of FIG. **11** is shown flipped as compared to FIG. **10**. Following the completion of the backgrinding process, a second etching step is performed to remove material of the contact pads **213** and to recess the contact pads **213** into the trace protection layer **102**.

Referring now to FIG. **12**, therein is shown the structure of FIG. **11** in a ball attach phase of manufacture. Following the second etching step to form the recess **318** in the trace protection layer **102**, the external connectors **104** can be deposited directly in the recess **318**, directly on the contact pads **213**, and without using a solder-wettable plating layer. This can be followed by a reflow step where the external connectors **104** are reflowed to fully cover the exposed surface of the contact pads **213** and fill the recess **318** in the trace protection layer **102**. The contact pads **213** recessed into the trace protection layer **102** can ensure a strong connection between the external connectors **104** and the contact pads **213** due to additional adhesion provided by contact with the sides of the trace protection layer **102** in the recess **318**. A singulation step cutting through the encapsulation **212** and the trace protection layer **102** between particular groups of the contact pads **213** to separate individual packages can complete the manufacturing of the integrated circuit packaging system **100**.

Referring now to FIG. **13**, therein is shown a detailed isometric view of FIG. **4** within the inset depicted by the dotted rectangle **13** of FIG. **4**. The detailed view is flipped in orientation from FIG. **4** and shows a portion of the pre-plated leadframe **422** having one of the contact protrusions **424** pre-plated with one of the protective pads **426**. The one of the protective pads **426** is shown with a visible thickness for clarity, but it is understood that the protective pads **426** can be as thick or as thin as is necessary.

Referring now to FIG. **14**, therein is shown the structure of FIG. **13** in a first molding phase of manufacture. The integrated circuit die **208** of FIG. **2** can be attached and connected to the pre-plated leadframe **422**, followed by the encapsulation **212** being applied to cover the integrated circuit die **208** and one side of the pre-plated leadframe **422**, leaving the contact protrusions **424** exposed.

Referring now to FIG. **15**, therein is shown the structure of FIG. **14** in a first etching phase of manufacture. The pre-plated leadframe **422** of FIG. **13** can be masked and etched to remove material from the contact protrusions **424** of FIG. **13** to form the contact pads **213** while also forming traces **1530** for routing to and from the contact pads **213**. The protective pads **426** on the contact protrusions **424** can prevent the etching process from decreasing the height of the contact

protrusions **424** as material is removed to form the contact pads **213**. The etching process can be controlled to stop etching as soon as the traces **1530** are fully formed on the encapsulation **212**, and the mask (not shown) can then be removed.

Referring now to FIG. **16**, therein is shown the structure of FIG. **15** in a second molding phase of manufacture. Following the formation of the traces **1530**, the trace protection layer **102** can be applied to fully cover and directly contact the traces **1530**, the contact pads **213**, and the protective pads **426** on the contact pads **213**. Features covered by the trace protection layer **102** are shown with dotted lines. Dotted lead lines are used to point to features that are not ordinarily visible. The trace protection layer **102** can be formed from the same material as the encapsulation **212** or from a different material. It is preferred for the purposes of preventing warpage and ease of manufacturing to use the same material as used to form the encapsulation **212**.

It has been discovered that the use of the same material for the trace protection layer **102** as the encapsulation **212** helps prevent warpage issues in the completed package. Warpage of a package generally occurs due to differences in the coefficient of thermal expansion between different materials. When the trace protection layer **102** and the encapsulation **212** are made from the same material, their coefficients of thermal expansion are exactly matched, helping to prevent the package from warping. This can also help prevent delamination between the encapsulation **212** and the trace protection layer **102**.

Referring now to FIG. **17A**, therein is shown the structure of FIG. **16** in a second etching phase of manufacture. After the application of the trace protection layer **102**, a backgrinding step can be performed on the trace protection layer **102**, also removing the protective pads **426** of FIG. **13** and a portion of the contact pads **213**.

The backgrinding step is followed by a second etching step, which can remove the material of the contact pads **213** without removing the material of the trace protection layer **102** so as to form the recess **318** in the trace protection layer **102** wherein the top surface of the contact pads **213** is the bottom of the recess **318** and is the recess distance **320** below the top surface of the trace protection layer **102**. The top surface of the contact pads **213** can also be called the external surface of the contact pads **213** because in this view, the orientation of the contact pads is inverted as compared to other figures showing the final product. In this example, the top surface of one of the contact pads **213** is shown as planar or flat, though it is understood that the top surface of the contact pads **213** can be concave or bowl-shaped due to an anisotropic etching method, with the central portion of the contact pads **213** lower than the outer edges. The etching process can leave the top surface of the contact pads **213** without defects.

Referring now to FIG. **17B**, therein is shown a detailed view of FIG. **17A** within the inset depicted by the solid rectangle **17** of FIG. **17A**. In this view can clearly be seen one of the contact pads **213**, the trace protection layer **102**, and the recess distance **320** between them.

Referring now to FIG. **18**, therein is shown the structure of FIG. **17A** in a ball attach phase of manufacture. Following the second etching step to form the recess **318** in the trace protection layer **102**, the external connectors **104** can be deposited directly in the recess **318**, directly on the contact pads **213**, and without using a solder-wettable plating layer. This can be followed by a reflow step where the external connectors **104**, such as solder balls, are reflowed to fully cover the exposed surface of the contact pads **213** and fill the recess **318** in the trace protection layer **102**. The contact pads **213** being

recessed into the trace protection layer **102** can ensure a strong connection is maintained between the external connectors **104** and the contact pads **213**.

Referring now to FIG. **19A**, therein is shown a cross-sectional view of the integrated circuit packaging system **1900** as exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in a second embodiment of the present invention. The cross-sectional view shows an integrated circuit die **1908**, bond structures **1910**, an encapsulation **1912**, contact pads **1913**, a solder resist layer **1932**, a trace protection layer **1902**, and external connectors **1904**. The integrated circuit die **1908**, such as a wire-bond die or a flip chip die, can be mounted to the solder resist layer **1932** using a die attach adhesive **1914**. The die attach adhesive **1914** can contact the bottom and a portion of the sides of the integrated circuit die **1908**. The solder resist layer **1932** can function to improve reliability of the package by covering traces and internal contact points and preventing electrical shorts between them.

The trace protection layer **1902** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **1902** is located under the integrated circuit die **1908** and in contact with the solder resist layer **1932**. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **1902** and route connections to and from the contact pads **1913**.

The solder resist layer **1932** can extend to the edges of the integrated circuit packaging system **1900** over and in contact with the contact pads **1913**. For example, the contact pads **1913** can be made from a conductive material such as copper or a copper alloy. The contact pads **1913** can have partially curved sides as a result of an etching process. The contact pads **1913** are in direct contact with the external connectors **1904** on a bottom surface and in direct contact with the bond structures **1910** on a top surface, which can be planar.

The external connectors **1904**, such as solder balls, can be connected to the contact pads **1913** through the trace protection layer **1902**. The external connectors **1904** function to electrically connect the integrated circuit die **1908** to the outside of the integrated circuit packaging system **1900**. The external connectors **1904** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **1910** can route electrical signals from the integrated circuit die **1908** to the contact pads **1913** directly or through traces. The bond structures **1910** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **1908** is connected to the bond structures **1910** and further to the contact pads **1913** and the external connectors **104** through internal interconnects **1916**, such as bond wires, solder balls, conductive posts, or conductive columns. The bond structures **1910** are covered by the solder resist layer **1932** except at points where the internal interconnects **1916** connect to the bond structures **1910**.

The encapsulation **1912** directly contacts the integrated circuit die **1908**, the solder resist layer **1932**, and the internal interconnects **1916**. The encapsulation **1912** is separated from the trace protection layer **1902** by the solder resist layer **1932**. The encapsulation **1912** can be made from the same kinds of material as the trace protection layer **1902**.

The contact pads **1913** are recessed into the trace protection layer **1902**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **1913** without intervening plating. The external

connectors **104** also directly contact the trace protection layer **1902**, creating a stronger solder joint.

Referring now to FIG. **19B**, therein is shown a cross-sectional view of the integrated circuit packaging system **1901** as exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in a third embodiment of the present invention. The cross-sectional view shows the integrated circuit die **1908**, the bond structures **1910**, the encapsulation **1912**, the contact pads **1913**, the solder resist layer **1932**, the trace protection layer **1902**, and the external connectors **1904**. The integrated circuit die **1908**, such as a wire-bond die or a flip chip die, can be mounted above the solder resist layer **1932**. The solder resist layer **1932** can function to improve reliability of the package by covering traces and internal contact points and preventing electrical shorts between them.

The trace protection layer **1902** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **1902** is located under the integrated circuit die **1908** and in contact with the solder resist layer **1932**. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **1902** and route connections to and from the contact pads **1913**.

The solder resist layer **1932** can extend to the edges of the integrated circuit packaging system **1900** over and in contact with the contact pads **1913**. For example, the contact pads **1913** can be made from a conductive material such as copper or a copper alloy. The contact pads **1913** can have partially curved sides as a result of an etching process. The contact pads **1913** are in direct contact with the external connectors **1904** on a bottom surface and in direct contact with the bond structures **1910** on a top surface. The bond structures **1910** can be planar.

The external connectors **1904**, such as solder balls, can be connected to the contact pads **1913** through the trace protection layer **1902**. The external connectors **1904** function to electrically connect the integrated circuit die **1908** to the outside of the integrated circuit packaging system **1901**. The external connectors **1904** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **1910** can route electrical signals from the integrated circuit die **1908** to the contact pads **1913** directly or through traces. The bond structures **1910** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **1908** is connected to the bond structures **1910** and further to the contact pads **1913** and the external connectors **104** through the internal interconnects **1916**, such as bond wires, solder balls, conductive posts, or conductive columns. The bond structures **1910** are covered by the solder resist layer **1932** except at points where the internal interconnects **1916** connect to the bond structures **1910**.

The encapsulation **1912** directly contacts the integrated circuit die **1908**, the solder resist layer **1932**, and the internal interconnects **1916**. The encapsulation **1912** is separated from the trace protection layer **1902** by the solder resist layer **1932**. The encapsulation **1912** can be made from the same kind of material as the trace protection layer **1902**.

The contact pads **1913** are recessed into the trace protection layer **1902**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **1913** without intervening plating. The external connectors **104** also directly contact the trace protection layer **1902**, creating a stronger solder joint.

11

Referring now to FIG. 20A, therein is shown a cross-sectional view of the integrated circuit packaging system 2000 as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a fourth embodiment of the present invention. The cross-sectional view shows an integrated circuit die 2008, bond structures 2010, an encapsulation 2012, contact pads 2013, a die paddle 2006, a trace protection layer 2002, and external connectors 2004. The integrated circuit die 2008, such as a wire-bond die or a flip chip die, can be mounted to the die paddle 2006 using a die attach adhesive 2014. The die attach adhesive 2014 can contact the bottom and a portion of the sides of the integrated circuit die 2008. The die paddle 2006 can function to dissipate heat or to provide a path to ground for the integrated circuit die 2008.

The trace protection layer 2002 protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer 2002 is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces 1530 of FIG. 15 are not shown in this figure, but the traces 1530 are covered by the trace protection layer 2002 and route connections to and from the contact pads 2013.

The die paddle 2006 can be laterally surrounded by the contact pads 2013, which are made from the same material as the die paddle 2006. For example, the die paddle 2006 and the contact pads 2013 can be made from a conductive material such as copper or a copper alloy. The die paddle 2006 and the contact pads 2013 can have partially curved sides as a result of an etching process. The contact pads 2013 are in direct contact with the external connectors 2004 on a bottom surface and in direct contact with the bond structures 2010 on a top surface. The bond structures 2010 can be planar.

The external connectors 2004, such as solder balls, can be connected to the contact pads 2013 through the trace protection layer 2002. The external connectors 2004 function to electrically connect the integrated circuit die 2008 to the outside of the integrated circuit packaging system 2000. The external connectors 2004 can be arranged in a staggered, regular, or irregular array, for example.

The bond structures 2010 can route electrical signals from the integrated circuit die 2008 to the contact pads 2013 directly or through traces. The bond structures 2010 can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die 2008 is connected to the bond structures 2010 and further to the contact pads 2013 and the external connectors 104 through internal interconnects 2016, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation 2012 directly contacts the integrated circuit die 2008, the bond structures 2010, and the internal interconnects 2016. The encapsulation 2012 also is in direct contact with portions of the trace protection layer 2002 between the contact pads 2013. The encapsulation 2012 can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads 2013 and the die paddle 2006 are recessed into the trace protection layer 2002, such as a second encapsulation layer, and the external connectors 104 directly contact the material of the contact pads 2013 without intervening plating. The external connectors 104 also directly contact the trace protection layer 2002, creating a stronger solder joint.

Referring now to FIG. 20B, therein is shown a cross-sectional view of the integrated circuit packaging system 2001 as

12

exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a fifth embodiment of the present invention. The cross-sectional view shows the integrated circuit die 2008, the bond structures 2010, the encapsulation 2012, the contact pads 2013, the die paddle 2006, the trace protection layer 2002, and the external connectors 2004. The integrated circuit die 2008, such as a wire-bond die or a flip chip die, can be mounted above the die paddle 2006. The die paddle 2006 can function to dissipate heat or to provide a path to ground for the integrated circuit die 2008.

The trace protection layer 2002 protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer 2002 is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces 1530 of FIG. 15 are not shown in this figure, but the traces 1530 are covered by the trace protection layer 2002 and route connections to and from the contact pads 2013.

The die paddle 2006 can be laterally surrounded by the contact pads 2013, which are made from the same material as the die paddle 2006. For example, the die paddle 2006 and the contact pads 2013 can be made from a conductive material such as copper or a copper alloy. The die paddle 2006 and the contact pads 2013 can have partially curved sides as a result of an etching process. The contact pads 2013 are in direct contact with the external connectors 2004 on a bottom surface and in direct contact with the bond structures 2010 on a top surface. The bond structures 2010 can be planar.

The external connectors 2004, such as solder balls, can be connected to the contact pads 2013 through the trace protection layer 2002. The external connectors 2004 function to electrically connect the integrated circuit die 2008 to the outside of the integrated circuit packaging system 2000. The external connectors 2004 can be arranged in a staggered, regular, or irregular array, for example.

The bond structures 2010 can route electrical signals from the integrated circuit die 2008 to the contact pads 2013 directly or through traces. The bond structures 2010 can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die 2008 is connected to the bond structures 2010 and further to the contact pads 2013 and the external connectors 104 through the internal interconnects 2016, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation 2012 directly contacts the integrated circuit die 2008, the bond structures 2010, and the internal interconnects 2016. The encapsulation 2012 also is in direct contact with portions of the trace protection layer 2002 between the contact pads 2013. The encapsulation 2012 can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads 2013 and the die paddle 2006 are recessed into the trace protection layer 2002, such as a second encapsulation layer, and the external connectors 104 directly contact the material of the contact pads 2013 without intervening plating. The external connectors 104 also directly contact the trace protection layer 2002, creating a stronger solder joint.

Referring now to FIG. 21A, therein is shown a cross-sectional view of the integrated circuit packaging system 2100 as exemplified by the bottom view of FIG. 1 and along the section line 2-2 of FIG. 1 in a sixth embodiment of the present invention. The cross-sectional view shows an integrated circuit die 2108, bond structures 2110, an encapsulation 2112, contact pads 2113, a die paddle 2106, a trace

13

protection layer **2102**, and external connectors **2104**. The integrated circuit die **2108**, such as a wire-bond die or a flip chip die, can be mounted to the die paddle **2106** using a die attach adhesive **2114**. The die attach adhesive **2114** can contact the bottom and a portion of the sides of the integrated circuit die **2108**. The die paddle **2106** can function to dissipate heat or to provide a path to ground for the integrated circuit die **2108**.

The trace protection layer **2102** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **2102** is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **2102** and route connections to and from the contact pads **2113**.

The die paddle **2106** can be laterally surrounded by the contact pads **2113**, which are made from the same material as the die paddle **2106**. For example, the die paddle **2106** and the contact pads **2113** can be made from a conductive material such as copper or a copper alloy. The die paddle **2106** and the contact pads **2113** can have partially curved sides as a result of an etching process. The contact pads **2113** are in direct contact with the external connectors **2104** on a bottom surface and in direct contact with a contact cap **2134** on a top surface. The bond structures **2110** can follow the contour of the combination of the contact pads **2113**, the die paddle **2106**, and the contact cap **2134** on the top surface of the contact pads **2113**. The contact cap **2134** can function to increase reliability by allowing for an overhang of the bond structures **2110**, which can help mold locking along with slightly decreasing bond distances.

The external connectors **2104**, such as solder balls, can be connected to the contact pads **2113** through the trace protection layer **2102**. The external connectors **2104** function to electrically connect the integrated circuit die **2108** to the outside of the integrated circuit packaging system **2100**. The external connectors **2104** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **2110** can route electrical signals from the integrated circuit die **2108** to the contact pads **2113** directly or through traces. The bond structures **2110** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **2108** is connected to the bond structures **2110** and further to the contact pads **2113** and the external connectors **2104** through internal interconnects **2116**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **2112** directly contacts the integrated circuit die **2108**, the bond structures **2110**, and the internal interconnects **2116**. The encapsulation **2112** also is in direct contact with portions of the trace protection layer **2102** between the contact pads **2113**. The encapsulation **2112** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **2113** and the die paddle **2106** are recessed into the trace protection layer **2102**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **2113** without intervening plating. The external connectors **2104** also directly contact the trace protection layer **2102**, creating a stronger solder joint.

Referring now to FIG. **21B**, therein is shown a cross-sectional view of the integrated circuit packaging system **2101** as

14

exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in a seventh embodiment of the present invention. The cross-sectional view shows the integrated circuit die **2108**, the bond structures **2110**, the encapsulation **2112**, the contact pads **2113**, the die paddle **2106**, the trace protection layer **2102**, and the external connectors **2104**. The integrated circuit die **2108**, such as a wire-bond die or a flip chip die, can be mounted to the die paddle **2106** using the die attach adhesive **2114**. The die attach adhesive **2114** can contact the bottom and a portion of the sides of the integrated circuit die **2108**. The die paddle **2106** can function to dissipate heat or to provide a path to ground for the integrated circuit die **2108**.

The trace protection layer **2102** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **2102** is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **2102** and route connections to and from the contact pads **2113**.

The die paddle **2106** can be laterally surrounded by the contact pads **2113**, which are made from the same material as the die paddle **2106**. For example, the die paddle **2106** and the contact pads **2113** can be made from a conductive material such as copper or a copper alloy. The die paddle **2106** and the contact pads **2113** can have partially curved sides as a result of an etching process. The contact pads **2113** are in direct contact with the external connectors **2104** on a bottom surface and in direct contact with the contact cap **2134** on a top surface. The bond structures **2110** can follow the contour of the combination of the contact pads **2113**, the die paddle **2106**, and the contact cap **2134** on the top surface of the contact pads **2113**. The contact cap **2134** can function to increase reliability by allowing for an overhang of the bond structures **2110**, which can help mold locking.

The external connectors **2104**, such as solder balls, can be connected to the contact pads **2113** through the trace protection layer **2102**. The external connectors **2104** function to electrically connect the integrated circuit die **2108** to the outside of the integrated circuit packaging system **2100**. The external connectors **2104** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **2110** can route electrical signals from the integrated circuit die **2108** to the contact pads **2113** directly or through traces. The bond structures **2110** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **2108** is connected to the bond structures **2110** and further to the contact pads **2113** and the external connectors **104** through the internal interconnects **2116**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **2112** directly contacts the integrated circuit die **2108**, the bond structures **2110**, and the internal interconnects **2116**. The encapsulation **2112** also is in direct contact with portions of the trace protection layer **2102** between the contact pads **2113**. The encapsulation **2112** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **2113** and the die paddle **2106** are recessed into the trace protection layer **2102**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **2113** without intervening

15

plating. The external connectors **104** also directly contact the trace protection layer **2102**, creating a stronger solder joint.

Referring now to FIG. **22A**, therein is shown a cross-sectional view of the integrated circuit packaging system **2200** as exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in an eighth embodiment of the present invention. The cross-sectional view shows an integrated circuit die **2208**, bond structures **2210**, an encapsulation **2212**, contact pads **2213**, a die paddle **2206**, a trace protection layer **2202**, and external connectors **2204**. The integrated circuit die **2208**, such as a wire-bond die or a flip chip die, can be mounted to the die paddle **2206** using a die attach adhesive **2214**. The die attach adhesive **2214** can contact the bottom and a portion of the sides of the integrated circuit die **2208**. The die paddle **2206** can function to dissipate heat or to provide a path to ground for the integrated circuit die **2208**.

The trace protection layer **2202** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **2202** is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **2202** and route connections to and from the contact pads **2213**.

The die paddle **2206** can be laterally surrounded by the contact pads **2213**, which are made from the same material as the die paddle **2206**. For example, the die paddle **2206** and the contact pads **2213** can be made from a conductive material such as copper or a copper alloy. The die paddle **2206** and the contact pads **2213** can have partially curved sides as a result of an etching process. The contact pads **2213** are in direct contact with the external connectors **2204** on a bottom surface and have a top surface which is partially etched to give a stepped structure. The bond structures **2210** can follow the contours of the stepped upper surface of the contact pads **2213**, and can overhang the contact pads **2213** to function to increase mold lock, increasing reliability.

The external connectors **2204**, such as solder balls, can be connected to the contact pads **2213** through the trace protection layer **2202**. The external connectors **2204** function to electrically connect the integrated circuit die **2208** to the outside of the integrated circuit packaging system **2200**. The external connectors **2204** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **2210** can route electrical signals from the integrated circuit die **2208** to the contact pads **2213** directly or through traces. The bond structures **2210** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **2208** is connected to the bond structures **2210** and further to the contact pads **2213** and the external connectors **104** through internal interconnects **2216**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **2212** directly contacts the integrated circuit die **2208**, the bond structures **2210**, and the internal interconnects **2216**. The encapsulation **2212** also is in direct contact with portions of the trace protection layer **2202** between the contact pads **2213**. The encapsulation **2212** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **2213** and the die paddle **2206** are recessed into the trace protection layer **2202**, such as a second encapsulation layer, and the external connectors **104** directly con-

16

tact the material of the contact pads **2213** without intervening plating. The external connectors **104** also directly contact the trace protection layer **2202**, creating a stronger solder joint.

Referring now to FIG. **22B**, therein is shown a cross-sectional view of the integrated circuit packaging system **2201** as exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in a ninth embodiment of the present invention. The cross-sectional view shows the integrated circuit die **2208**, the bond structures **2210**, the encapsulation **2212**, the contact pads **2213**, the die paddle **2206**, the trace protection layer **2202**, and the external connectors **2204**. The integrated circuit die **2208**, such as a wire-bond die or a flip chip die, can be mounted above the die paddle **2206**. The die paddle **2206** can function to dissipate heat or to provide a path to ground for the integrated circuit die **2208**.

The trace protection layer **2202** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **2202** is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **2202** and route connections to and from the contact pads **2213**.

The die paddle **2206** can be laterally surrounded by the contact pads **2213**, which are made from the same material as the die paddle **2206**. For example, the die paddle **2206** and the contact pads **2213** can be made from a conductive material such as copper or a copper alloy. The die paddle **2206** and the contact pads **2213** can have partially curved sides as a result of an etching process. The contact pads **2213** are in direct contact with the external connectors **2204** on a bottom surface and have a top surface which is partially etched to give a stepped structure. The bond structures **2210** can follow the contours of the stepped upper surface of the contact pads **2213**, and can overhang the contact pads **2213** to function to increase mold lock, increasing reliability.

The external connectors **2204**, such as solder balls, can be connected to the contact pads **2213** through the trace protection layer **2202**. The external connectors **2204** function to electrically connect the integrated circuit die **2208** to the outside of the integrated circuit packaging system **2200**. The external connectors **2204** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **2210** can route electrical signals from the integrated circuit die **2208** to the contact pads **2213** directly or through traces. The bond structures **2210** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **2208** is connected to the bond structures **2210** and further to the contact pads **2213** and the external connectors **104** through the internal interconnects **2216**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **2212** directly contacts the integrated circuit die **2208**, the bond structures **2210**, and the internal interconnects **2216**. The encapsulation **2212** also is in direct contact with portions of the trace protection layer **2202** between the contact pads **2213**. The encapsulation **2212** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **2213** and the die paddle **2206** are recessed into the trace protection layer **2202**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **2213** without intervening

17

plating. The external connectors **104** also directly contact the trace protection layer **2202**, creating a stronger solder joint.

Referring now to FIG. **23A**, therein is shown a cross-sectional view of the integrated circuit packaging system **2300** as exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in a tenth embodiment of the present invention. The cross-sectional view shows an integrated circuit die **2308**, bond structures **2310**, an encapsulation **2312**, contact pads **2313**, a trace protection layer **2302**, and external connectors **2304**. The integrated circuit die **2308**, such as a wire-bond die or a flip chip die, can be mounted to the contact pads **2313** which are centrally located using a die attach adhesive **2314**. The die attach adhesive **2314** can contact the bottom and a portion of the sides of the integrated circuit die **2308**.

The trace protection layer **2302** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **2302** is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **2302** and route connections to and from the contact pads **2313**.

For example, the contact pads **2313** can be made from a conductive material such as copper or a copper alloy. The contact pads **2313** can have partially curved sides as a result of an etching process. The contact pads **2313** are in direct contact with the external connectors **2304** on a bottom surface and can either have a flat top surface or a top surface which is partially etched to give a stepped structure. The bond structures **2310** can follow the contours of the stepped upper surface of the contact pads **2313**, and can overhang the contact pads **2313** to function to increase mold lock, increasing reliability. The contact pads **2313** can be arranged in a full array, with no die paddle present, simplifying manufacturing.

The external connectors **2304**, such as solder balls, can be connected to the contact pads **2313** through the trace protection layer **2302**. The external connectors **2304** function to electrically connect the integrated circuit die **2308** to the outside of the integrated circuit packaging system **2300**. The external connectors **2304** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **2310** can route electrical signals from the integrated circuit die **2308** to the contact pads **2313** directly or through traces. The bond structures **2310** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **2308** is connected to the bond structures **2310** and further to the contact pads **2313** and the external connectors **104** through internal interconnects **2316**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **2312** directly contacts the integrated circuit die **2308**, the bond structures **2310**, and the internal interconnects **2316**. The encapsulation **2312** also is in direct contact with portions of the trace protection layer **2302** between the contact pads **2313**. The encapsulation **2312** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **2313** are recessed into the trace protection layer **2302**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **2313** without intervening plating. The external connectors **104** also directly contact the trace protection layer **2302**, creating a stronger solder joint.

18

Referring now to FIG. **23B**, therein is shown a cross-sectional view of the integrated circuit packaging system **2301** as exemplified by the bottom view of FIG. **1** and along the section line **2-2** of FIG. **1** in an eleventh embodiment of the present invention. The cross-sectional view shows the integrated circuit die **2308**, the bond structures **2310**, the encapsulation **2312**, the contact pads **2313**, the trace protection layer **2302**, and the external connectors **2304**. The integrated circuit die **2308**, such as a wire-bond die or a flip chip die, can be mounted over the contact pads **2313** which are centrally located.

The trace protection layer **2302** protects and holds traces and contacts in place, and can be made from a material such as epoxy molding compound, resin, moldable underfill, a curable compound, or other non-conductive material. The trace protection layer **2302** is shown as opaque, but it is understood that a translucent or transparent material may be used. The traces **1530** of FIG. **15** are not shown in this figure, but the traces **1530** are covered by the trace protection layer **2302** and route connections to and from the contact pads **2313**.

For example, the contact pads **2313** can be made from a conductive material such as copper or a copper alloy. The contact pads **2313** can have partially curved sides as a result of an etching process. The contact pads **2313** are in direct contact with the external connectors **2304** on a bottom surface and can either have a flat top surface or a top surface which is partially etched to give a stepped structure. The bond structures **2310** can follow the contours of the stepped upper surface of the contact pads **2313**, and can overhang the contact pads **2313** to function to increase mold lock, increasing reliability. The contact pads **2313** can be arranged in a full array, with no die paddle present, simplifying manufacturing.

The external connectors **2304**, such as solder balls, can be connected to the contact pads **2313** through the trace protection layer **2302**. The external connectors **2304** function to electrically connect the integrated circuit die **2308** to the outside of the integrated circuit packaging system **2300**. The external connectors **2304** can be arranged in a staggered, regular, or irregular array, for example.

The bond structures **2310** can route electrical signals from the integrated circuit die **2308** to the contact pads **2313** directly or through traces. The bond structures **2310** can be made of conductive material such as gold, silver, nickel, palladium, tungsten, other metals, or a combination thereof. The integrated circuit die **2308** is connected to the bond structures **2310** and further to the contact pads **2313** and the external connectors **104** through the internal interconnects **2316**, such as bond wires, solder balls, conductive posts, or conductive columns.

The encapsulation **2312** directly contacts the integrated circuit die **2308**, the bond structures **2310**, and the internal interconnects **2316**. The encapsulation **2312** also is in direct contact with portions of the trace protection layer **2302** between the contact pads **2313**. The encapsulation **2312** can be made from a material such as epoxy molding compound, curable underfill, or other moldable compound.

The contact pads **2313** are recessed into the trace protection layer **2302**, such as a second encapsulation layer, and the external connectors **104** directly contact the material of the contact pads **2313** without intervening plating. The external connectors **104** also directly contact the trace protection layer **2302**, creating a stronger solder joint.

Referring now to FIG. **24**, therein is shown a flow chart of a method **2400** of manufacture of the integrated circuit packaging system **100** in a further embodiment of the present invention. The method **2400** includes: providing a pre-plated

19

leadframe having a contact protrusion and a protective pad on the contact protrusion in a block **2402**; forming a contact pad and traces by etching the pre-plated leadframe in a block **2404**; applying a trace protection layer on the contact pad, the traces, and the protective pad in a block **2406**; removing the protective pad and a portion of the trace protection layer for exposing the contact pad in a block **2408**; and depositing an external connector directly on a surface of the contact pad in a block **2410**.

Thus, it has been discovered that the method of manufacture of the integrated circuit packaging system **100** of the present invention furnishes important and heretofore unknown and unavailable solutions, capabilities, and functional aspects for cost-effective and reliable manufacture of the integrated circuit packaging system **100**.

The resulting method, process, apparatus, device, product, and/or system is straightforward, cost-effective, uncomplicated, highly versatile, accurate, sensitive, and effective, and can be implemented by adapting known components for ready, efficient, and economical manufacturing, application, and utilization.

Another important aspect of the present invention is that it valuably supports and services the historical trend of reducing costs, simplifying systems, and increasing performance.

These and other valuable aspects of the present invention consequently further the state of the technology to at least the next level.

While the invention has been described in conjunction with a specific best mode, it is to be understood that many alternatives, modifications, and variations will be apparent to those skilled in the art in light of the foregoing description. Accordingly, it is intended to embrace all such alternatives, modifications, and variations that fall within the scope of the included claims. All matters hithertofore set forth herein or shown in the accompanying drawings are to be interpreted in an illustrative and non-limiting sense.

What is claimed is:

1. A method of manufacture of an integrated circuit packaging system comprising:

providing a pre-plated leadframe having a contact protrusion and a protective pad on the contact protrusion; forming a contact pad and traces by etching the pre-plated leadframe; applying a trace protection layer on the contact pad, the traces, and the protective pad; removing the protective pad and a portion of the trace protection layer for exposing a surface of the contact pad; and depositing an external connector directly on the surface of the contact pad.

2. The method as claimed in claim 1 wherein removing the protective pad and a portion of the trace protection layer includes using a backgrinding tool.

3. The method as claimed in claim 1 further comprising forming a recess in the trace protection layer by etching the surface of the contact pad to a recess distance from an exposed surface of the trace protection layer.

4. The method as claimed in claim 1 further comprising: connecting an integrated circuit die to the contact protrusion; and depositing an encapsulation on the integrated circuit die and the pre-plated leadframe.

5. The method as claimed in claim 1 wherein providing the pre-plated leadframe includes providing the pre-plated leadframe having bond structures opposite the protective pad.

20

6. A method of manufacture of an integrated circuit packaging system comprising:

providing a pre-plated leadframe having a contact protrusion, a protective pad on the contact protrusion, and bond structures opposite the protective pad;

connecting an integrated circuit die to the bond structures; depositing an encapsulation on the integrated circuit die and the bond structures of the pre-plated leadframe;

forming a contact pad and traces by etching the pre-plated leadframe;

applying a trace protection layer on the contact pad, the traces, and the protective pad;

removing the protective pad and a portion of the trace protection layer for exposing the contact pad using a backgrinding tool;

forming a recess in the trace protection layer by etching the surface of the contact pad to a recess distance from an exposed surface of the trace protection layer the surface of the contact pad only exposed in the recess; and depositing an external connector directly on a surface of the contact pad.

7. The method as claimed in claim 6 wherein depositing the external connector includes depositing the external connector in the recess.

8. The method as claimed in claim 6 wherein removing the portion of the trace protection layer using a backgrinding tool includes forming the exposed surface of the trace protection layer as uniformly planar.

9. The method as claimed in claim 6 wherein providing the pre-plated leadframe includes providing the pre-plated leadframe having bond structures opposite the protective pad; and further comprising:

connecting an internal interconnect to the integrated circuit die and the bond structures.

10. The method as claimed in claim 6 wherein applying the trace protection layer includes applying the same material for the trace protection layer as for the encapsulation.

11. An integrated circuit packaging system comprising:

an integrated circuit die; a contact pad connected to the integrated circuit die; traces connected to the contact pad; a trace protection layer on the contact pad and the traces, the trace protection layer having a recess with an external surface of the contact pad only exposed in the recess and the contact pad spaced a recess distance away from an exposed surface of the trace protection layer; and an external connector directly on the external surface of the contact pad.

12. The system as claimed in claim 11 further comprising: bond structures on the contact pad; and an encapsulation on the integrated circuit die and the bond structures.

13. The system as claimed in claim 11 wherein the contact pad is without a plating layer.

14. The system as claimed in claim 11 wherein the exposed surface of the trace protection layer is uniformly planar.

15. The system as claimed in claim 11 further comprising a die paddle adjacent the contact pad.

16. The system as claimed in claim 11 further comprising: a die paddle adjacent the contact pad; bond structures on the die paddle and the contact pad; and an encapsulation on the integrated circuit die and the bond structures.

17. The system as claimed in claim 16 wherein the integrated circuit die is mounted on the die paddle.

21

18. The system as claimed in claim **16** further comprising an internal interconnect on and between the integrated circuit die and the bond structures.

19. The system as claimed in claim **16** wherein the encapsulation and the trace protection layer are formed from the same material. 5

20. The system as claimed in claim **16** wherein the encapsulation and the trace protection layer are formed from epoxy molding compound.

* * * * *

10

22